

SEMICON Japan 2009 REPORT

Connect the World, Protect the Earth and Shape the Future!

Dates: Wednesday, December 2 – Friday, December 4
 Venue: Makuhari Messe, Chiba Japan
 Organizer: SEMI®

1. Exhibition () = Previous

Exhibitors: 924 exhibitors (1,477 exhibitors)
 Number of Booths: 2,204 booths (4,450 booths)
 Number of Countries: 19 countries/ regions (22 countries/ regions)

●Country/ Region

Country/ Region	Number	Country/ Region	Number
Japan	751	Taiwan	5
U.S.A.	75	Israel	1
Korea	33	China	7
Germany	22	Canada	2
France	6	Singapore	4
U.K.	6	Other	12
		Total	924

2. Total Verified Visitors () = Previous

	Number (Previous)
Exhibition Visitors	29,529 (51,387)
Seminar Attendees	2,880 (2,438)

This is the number of unique visitors; i.e. people who attended on more than one day are counted only once. In addition, exhibition visitors number 29,592 does not include 3,146 exhibitors who registered as visitors.

3. Visitors () = Previous

Total Visitors: 64,100 (97,000) approx.

●Total Daily Visitors

Date	Number (Previous)
Wednesday, Dec. 2	21,500 (31,500)
Thursday, Dec. 3	20,700 (32,700)
Friday, Dec. 4	21,900 (32,800)
Total	64,100 (97,000)

(The approx. number of daily visitors includes estimated exhibitors # of each day)

4. Opening Ceremony

Date: Dec. 2, 2009 a.m. 9:30-10:00

Venue: International Conference Room, International Conference Hall 2F, Makuhari Messe

Opening Speech	SEMI Japan President	Hank Nakagawa
Welcome Remarks	Chairman, SEMI Board of Directors Representative Director and Chairman, Edwards Korea Ltd.	JC Kim
Guest Speech	Governor of Chiba Prefecture	Kensaku Morita
Guest Speech	Director, Industrial Machinery Division Ministry of Economy Trade and Industry	Takeshi Yonemura
Remarks representing Device Manufacturer	Representative Director, Chairman Renesas Technology Corp.	Katsuhiko Tsukamoto
Remarks representing	Chairman, SEMICON Japan 2009 Advisory Committee Corporate Officer, Executive Vice President, Semiconductor Equipment Company, Dainippon Screen Mfg. Co., Ltd. President, Chief Executive Officer, SOKUDO Co., Ltd.	Tadahiro Suhara
Introduction of SEMI Board Members & Show Committee Members		
Ribbon Cutting	Governor of Chiba Prefecture METI Renesas Technology Corp. Hynix Semiconductor Inc. Edwards Korea Ltd. Dainippon Screen Mfg. Co., Ltd. SEMI SEMI Japan	Kensaku Morita Takeshi Yonemura Katsuhiko Tsukamoto J.K. Kim J.C. Kim Tadahiro Suhara Stan Myers Hank Nakagawa

5. SEMI Presidents Reception 2009

<i>Date</i>	<i>Programs</i>	<i>Venue</i>	<i>Attendee</i>
12/2	SEMI Presidents Reception	Convention Hall B, International Conference Hall, Makuhari Messe	258

Date/Time: 18:00 – 19:30 Wednesday, December 2, 2009

Venue: Convention Hall B, International Conference Hall, Makuhari Messe

18:00-18:02	<p>Opening remarks Hank Nakagawa, President, SEMI Japan</p>
18:02-18:05	<p>Welcome remarks JC Kim, Chairman, SEMI Board of Directors (Representative Director and Chairman, Edwards Korea Ltd)</p>
18:05-18:08	<p>Guest speech Hideo Kawasaki, President, Semiconductor Company, Panasonic Corporation</p>
18:08-18:18	<p>The Akira Inoue Award Ceremony Awardee: JK Kim, Chairman and CEO, Hynix Semiconductor</p> <ul style="list-style-type: none"> - Announce the awardee's name Mary Puma, Chairman and CEO, Axcelis Technologies (Chairman of the SEMI EHS Executive Committee) - Awardee to receive the award Presenters: Mary Puma, Chairman and CEO, Axcelis Technologies and SEMI EHS Executive Committee Stan Myers, President and CEO, SEMI - Acceptance Speech JK Kim, Chairman and CEO, Hynix Semiconductor
18:18-18:23	<p>Kagamibiraki (Sake Ceremony)</p> <ul style="list-style-type: none"> - Takeshi Yonemura, Director, Industrial Machinery Division, METI - Hideo Kawasaki, President, Semiconductor Company, Panasonic - JK Kim, Chairman and CEO, Hynix Semiconductor - Mike Polcari, Chairman of the Board, SEMATECH - Tadahiro Suhara, Corporate Officer, Executive Vice President, Semiconductor Equipment Company, Dainippon Screen Mfg. Co., Ltd. (Chairman, SEMICON Japan 2009 Advisory Committee) - JC Kim, Representative Director and Chairman, Edwards Korea Chairman, SEMI Board of Directors - Stan Myers, President and CEO, SEMI
18:23-18:25	<p>Kampai (Toast) Mike Polcari, Chairman of the Board, SEMATECH</p>
18:25-19:15	<p>Kandan (Free Time)</p>
19:18	<p>Nakajime (middle ending) speech Tadahiro Suhara, Corporate Officer, Executive Vice President, Semiconductor Equipment Company, Dainippon Screen Mfg. Co., Ltd. (Chairman, SEMICON Japan 2009 Advisory Committee)</p>
19:30	<p>Adjourn</p>

6. SEMI Special Programs

Date	Programs	Venue	Attendee
Dec. 2	SEMICON Japan/STS 2009 Keynote Addresses: Image Sensor	Makuhari Messe Int'l Conference Hall	281
Dec. 3	SEMICON Japan/STS 2009 Keynote Addresses: EV	Makuhari Messe Int'l Conference Hall	278
Dec. 4	SEMICON Japan/STS 2009 Keynote Addresses: LED	Makuhari Messe Int'l Conference Hall	415
Dec.2-4	Let's Go to SEMICON !	Makuhari Messe Hall 6	182
Dec 3-4	HTU@SEMICON	Makuhari Messe Hall 6	69
Dec.2-4	Process Booth Tour	Makuhari Messe Hall 2-8	55
Dec. 2	Nano-imprint academic workshop by JJAP	Special Presentation Stage, Special Pavillion	125
Dec. 2	Nano-imprint exhibitor workshop	Special Presentation Stage, Special Pavillion	100
Dec. 3	MEMS workshop by JJAP	Special Presentation Stage, Special Pavillion	95
Dec. 3	Academic roadmap keynote and workshop by JJAP	Special Presentation Stage, Special Pavillion	126
Dec. 3	Nikkei Microdevice & SEMI Presents Special Stage 1	Special Presentation Stage, Special Pavillion	285
Dec. 3	Pavilion exhibitor workshop I	Special Presentation Stage, Special Pavillion	53
Dec. 4	Nikkei Microdevice & SEMI Presents Special Stage 2	Special Presentation Stage, Special Pavillion	415
Dec. 4	Pavilion exhibitor workshop II	Special Presentation Stage, Special Pavillion	51

7. SEMI Technology Symposium (STS) 2009

Date	Programs	Venue	Attendee
Dec. 2	STS S1: Microsystems/MEMS (1)	Makuhari Messe Int'l Conference Hall	134
Dec. 2	STS S2: Microsystems/MEMS (2)	Makuhari Messe Int'l Conference Hall	98
Dec. 2	STS S3: Strategy	Makuhari Messe Int'l Conference Hall	116
Dec. 3	STS S4: Lithography/Mask (1)	Makuhari Messe Int'l Conference Hall	118
Dec. 3	STS S5: Lithography/Mask (2)	Makuhari Messe Int'l Conference Hall	109
Dec. 3	STS S6: Manufacturing Science	Makuhari Messe Int'l Conference Hall	76
Dec. 3	STS S7: Etching	Makuhari Messe Int'l Conference Hall	98
Dec. 3	STS S8: Special Program -Next Generation Transportation Systems	Makuhari Messe Int'l Conference Hall	73
Dec. 3	STS S9: Testing	Makuhari Messe Int'l Conference Hall	88
Dec. 4	STS S10: Multi-Level Interconnection	Makuhari Messe Int'l Conference Hall	62
Dec. 4	STS S11: Advanced Device	Makuhari Messe Int'l Conference Hall	84
Dec. 4	STS S12: Packaging (1)	Makuhari Messe Int'l Conference Hall	89
Dec. 4	STS S13: Packaging (2)	Makuhari Messe Int'l Conference Hall	83
Dec. 4	STS S14: DFM	Makuhari Messe Int'l Conference Hall	59

8. Technical/ Business Programs

Date	Programs	Venue	Attendee
Dec. 2	ISMI Next Generation Factory e-Manufacturing	Makuhari Messe Int'l Conference Hall	60
Dec. 2	International EHS Compliance and Regulatory Seminar	Makuhari Messe Int'l Conference Hall	32
Dec. 2	4th SEMI Photovoltaic Technology Symposium	Makuhari Messe Int'l Conference Hall	122
Dec. 2	Preventing Counterfeiting of Semiconductors through Traceability	Special Presentation Stage, Special Pavillion	150
Dec. 4	SEMI Market Seminar	Makuhari Messe Int'l Conference Hall	109
Dec. 4	Semiconductor Used Equipment Business Seminar	Makuhari Messe Int'l Conference Hall	46
Dec. 3	The 10th SEMI Global Environment Symposium	Makuhari Messe Int'l Conference Hall	52

9. SEMI Standards Technical Programs

Date	Programs	Venue	Attendee
Dec. 1	STEP/SEMI S2	Makuhari Messe Int'l Conference Hall	21
Dec. 2	STEP/SEMI S22 and Electrical Safety Design of EHS Semiconductor/FPD Manufacturing Equipment	Makuhari Messe Int'l Conference Hall	40
Dec. 2	Assess and Control Electrostatic Discharge (ESD) for Equipment	Makuhari Messe Int'l Conference Hall	23
Dec. 3	Metrics-Related Standardization and its Impact on New Generation Semiconductor Industry	Makuhari Messe Int'l Conference Hall	16
Dec. 3	Advanced Wafer Tuning	Makuhari Messe Int'l Conference Hall	42

10. Meetings, etc.

Date	Programs	Venue	Attendee
Dec. 1-4	Standards Meeting (40 meetings)	Makuhari Messe Int'l Conference Hall, SEMI Japan	538
Dec. 1-4	EHS & Advocacy Meeting (13 meetings)	Makuhari Messe Int'l Conference Hall, SEMI Japan	101
Dec. 3	SEMI Standard Award Ceremony, Friendship Party		85